

<b>Search Notes</b>  	<b>Application/Control No.</b>	<b>Applicant(s)/Patent Under Reexamination</b>
	10666309	CREAMER ET AL.
	<b>Examiner</b>  Park, Jeong S	<b>Art Unit</b>  2109

### SEARCHED

<b>Class</b>	<b>Subclass</b>	<b>Date</b>	<b>Examiner</b>
709	224	4/2/2007	Jeong Park

### SEARCH NOTES

<b>Search Notes</b>	<b>Date</b>	<b>Examiner</b>
limited text search of 709/224 with terms of "monitoring or monitored", "system", "behavior or pattern", "web"	4/2/2007	Jeong Park
limited text search of 709/224 with terms of "monitoring or monitored", "system", "behavior", "multiple or plurality"	4/5/2007	Jeong Park

### INTERFERENCE SEARCH

<b>Class</b>	<b>Subclass</b>	<b>Date</b>	<b>Examiner</b>